

Volume 30 (2023)

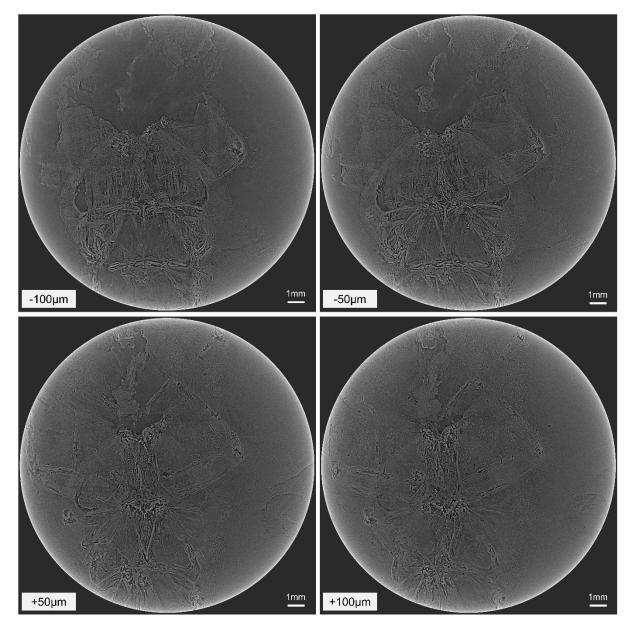
Supporting information for article:

High-energy X-ray micro-laminography to visualize microstructures in dense planar objects

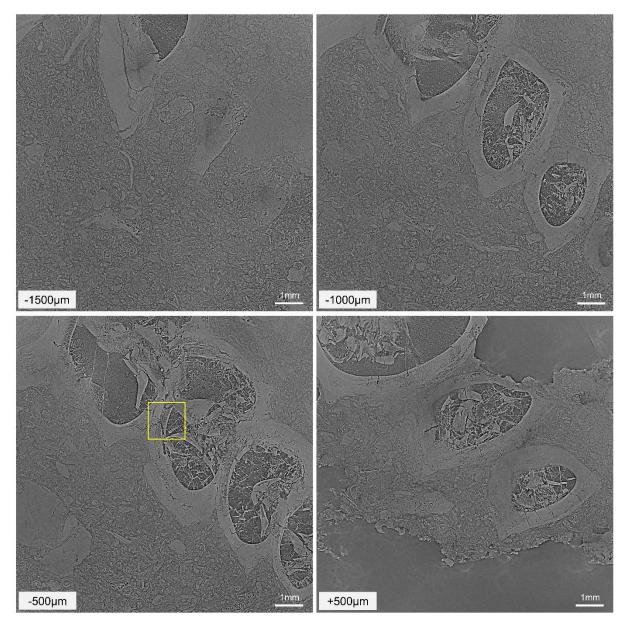
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## S1. High-resolution sectional images obtained from X-ray micro-laminography

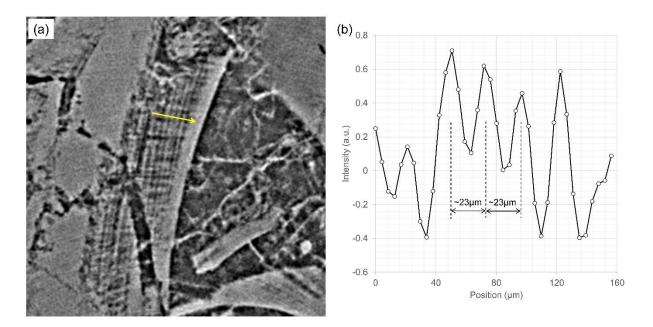
Additional sectional images of FPDM-I-145 and FPDM-I-2337 obtained from high-resolution X-ray micro-LG are shown in Fig. S1 and S2, respectively. A magnified image at the square region in Fig. S2 is shown in Fig. S3(a). A line profile measured at the periodic structure indicated by the arrowed line is shown in Fig. S3(b). The periodic structure of approximately 23  $\mu$ m (5.5 pixels) can be clearly resolved.



**Figure S1** Sectional images of a FPDM-I-145. Numerical value shown in lower left in each image represents a distance from the sectional plane shown in Fig. 3(c).



**Figure S2** Sectional images of FPDM-I-2337. Numerical value shown in lower left in each image represents a distance from the sectional plane shown in Fig .4(a).



**Figure S3** (a) Magnified image at the square region shown in Fig. S2. (b) Line profile measured at the arrowed line in (a).

## S2. Sequential slices along the depth direction

A video in .avi format comparing sequential slices of FPDM- I-145 along the same depth direction under X-ray micro-CT (left) and X-ray micro-LG (right).